IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Kazuo TESHIROGI et al.

Serial Number: Not Yet Assigned

Filed: November 24, 2003 Customer No.: 38834

For: FILM LAMINATION APPARATUS AND METHOD AND A MANUFACTURING METHOD OF A SEMICONDUCTOR APPARATUS

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P. O. Box 1450 Alexandria, VA 22313-1450

November 24, 2003

Sir:

In compliance with 37 CFR 1.56, Applicant calls to the attention of the Patent and Trademark Office the references listed on the attached.

A copy of each of the references is enclosed herewith.

In the event there are any fees due in connection with the filing of this paper, please charge

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Enclosures: PTO-1449; References (2)

Atty. Docket No. 032131 Serial No. New Appln. **INFORMATION DISCLOSURE** Applicant(s): Kazuo TESHIROGI et al. **STATEMENT** PTO-1449 Group Art Unit: Filing Date: November 24, 2003 **U.S. PATENT DOCUMENTS** Filing Date Subclass Document No. Name Class Examiner Date Initial (If appropriate) AA AB ACAD FOREIGN PATENT DOCUMENTS Translation Document No. Date Country (Yes or No) Abstract. Cited in the specification 03/22/95 Japan -7-25463 AE Abstract. Cited in the specification ΑF 2002-76096 03/15/02 Japan AG AH ΑI ΑJ ΑK OTHER DOCUMENTS AL AM

Date Considered

AN

Examiner